

TRADEMARK ASSIGNMENT

Electronic Version v1.1
 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT		
NATURE OF CONVEYANCE:	Termination of Debtor-in-Possession Intellectual Property Security Agreement		
CONVEYING PARTY DATA			
Name	Formerly	Execution Date	Entity Type
Wells Fargo Bank, N.A.		08/24/2010	COMPANY: DELAWARE
RECEIVING PARTY DATA			
Name:	EPV Solar, Inc.		
Street Address:	8 Marlen Drive		
City:	Robbinsville		
State/Country:	NEW JERSEY		
Postal Code:	08690		
Entity Type:	CORPORATION: NEW JERSEY		
Name:	EPV Solar Germany GmbH		
Street Address:	8 Marlen Drive		
City:	Robbinsville		
State/Country:	NEW JERSEY		
Postal Code:	08690		
Entity Type:	COMPANY: GERMANY		
PROPERTY NUMBERS Total: 3			
Property Type	Number	Word Mark	
Registration Number:	2614699	EPV	
Registration Number:	2612208	EPV-40	
Registration Number:	3121710	EPV OUTSIDE	
CORRESPONDENCE DATA			
Fax Number:	(617)856-8201		
	<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>		
Phone:	617-856-8145		
Email:	ip@brownrudnick.com		

CH \$90.00 2614699

Correspondent Name: Mark S. Leonardo
Address Line 1: One Financial Center
Address Line 2: Brown Rudnick LLP
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ATTORNEY DOCKET NUMBER:	28869/1
NAME OF SUBMITTER:	Mark S. Leonardo
Signature:	/Mark S. Leonardo/
Date:	09/13/2010

Total Attachments: 6

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**TERMINATION OF DEBTOR-IN-POSSESSION INTELLECTUAL PROPERTY SECURITY
AGREEMENT
(PATENTS & TRADEMARKS)**

This Termination of Debtor-in-Possession Intellectual Property Security Agreement, dated as of August 27, 2010, is executed by WELLS FARGO BANK, N.A., as Agent, having a place of business at 45 Broadway, 14th Floor, New York, New York 10006 as Agent (the "Agent") for itself and the Lenders, for the purpose of releasing the security interest of the Agent in the Intellectual Property (as defined below) owned by EPV SOLAR, INC., a New Jersey corporation and EPV SOLAR GERMANY GMBH, a German Company (the "Grantors").

Recitals

WHEREAS, the Agent was granted by Grantors, a security interest in the Patents and Trademarks of the Grantors, listed on **Schedule A** hereto (collectively, the "Intellectual Property") pursuant to that certain Debtor-in-Possession Intellectual Property Security Agreement dated as of March 25, 2010 and recorded in the United States Patent and Trademark Office on March 26, 2010 at Reel 024140, Frame 0472 and at Reel 004175, Frame 0166 respectively;

WHEREAS, Agent has agreed to terminate and release its security interest in the Intellectual Property;
and

WHEREAS, Agent wishes to provide a document suitable for recording in the United States Patent and Trademark Office for purposes of recording the termination and release of the security interest in and to the Intellectual Property previously granted by Grantors to Agent.

NOW, THEREFORE, in consideration of the premises and other good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, Agent hereby agrees as follows:

The Agent hereby terminates and releases the Agent's security interest in the Intellectual Property as set forth at the Reel and Frame numbers referenced above.

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WELLS FARGO BANK, N.A., as Agent

By: 

Title: Vice President

SCHEDULE A

Trademarks

MARK	OWNER	COUNTRY	APPL NO	CLASS	FILED	REG NO	REG DT	STATUS
EPV	EPV Solar, Inc.	US	76/240,598	9	4/16/01	2,614,699	9/03/82	Canceled
EPV-40	EPV Solar, Inc.	US	76/240,599	9	4/16/01	2,612,208	8/27/02	Canceled
EPV Outside	EPV Solar, Inc.	US	76/450,062	9	7/13/04	3,121,710	7/25/06	Registered

U.S. Patents

Patent No./Issue Date	Publication No./ Publication Date	Title
7,652,209 01-26-2010	2006-0144436 07-06-2006	METHOD OF JUNCTION FORMATION FOR CIGS PHOTOVOLTAIC DEVICES
7,235,160 06-26-2007	2005-0029088 02-10-2005	HOLLOW CATHODE SPUTTERING APPARATUS AND RELATED METHOD
7,019,208 03-28-2006	2003-0102023 06-05-2003	METHOD OF JUNCTION FORMATION FOR CIGS PHOTOVOLTAIC DEVICES
6,660,538 12-09-2003	2003-0082834 05-01-2003	NON-CONTACTING DEPOSITION CONTROL OF CHALCOPYRITE THIN FILMS

Patent Applications Filed and Pending

Serial No./Filing Date	Publication No./ Publication Date	Title
12/557,389 09-10-2009	N/A	MOUNTING SYSTEMS FOR PHOTOVOLTAIC MODULES
12/488,218 TBD	N/A	METHOD FOR FABRICATING A DOPED AND/OR ALLOYED SEMICONDUCTOR
12/466,141 05-14-2009	2009/0301551 12-10-2009	SILICON FILM DEPOSITION METHOD UTILIZING A SILENT ELECTRIC DISCHARGE AND AN ACTIVE SPECIES
12/466,137 05-14-2009	2009/0293943 12-03-2009	SILICON FILM DEPOSITION METHOD UTILIZING A SILENT ELECTRIC DISCHARGE
12/422,004 04-10-2009	2009/0255582 10-15-2009	METHODS OF DRYING GLASS FOR PHOTOVOLTAIC APPLICATIONS
12/410,297 3-24-2009	2009/0235987 09-14-2009	CHEMICAL TREATMENTS TO ENHANCE PHOTOVOLTAIC PERFORMANCE OF CIGS
12/395,889 03-02-2009	N/A	INSULATED GLASS UNIT WITH INTEGRATED MINI-JUNCTION BOX

Serial No./Filing Date	Publication No./ Publication Date	Title
12/127,470 05-27-2008	2008/0308411 12-18-2008	METHOD AND PROCESS FOR DEPOSITION OF TEXTURED ZINC OXIDE THIN FILMS
11/768,652 06-26-2007	2007/0256926 11-08-2007	HOLLOW CATHODE SPUTTERING APPARATUS AND RELATED METHOD
11/275,079 12-08-2005	2006/0118406 06-08-2006	SPUTTERED TRANSPARENT CONDUCTIVE FILMS
61/097,769 09-17-08	N/A	LARGE BATCH PRODUCTION OF THIN PHOTOVOLTAIC MODULES

Non-U.S. Patent Applications

Patent No./Issue Date	Publication No./ Publication Date	Title	National Filing Due Date (31 Month)
PCT/US2009/001318 03-02-2009	WO 2009/108385 09-03-2009	INSULATED GLASS UNIT WITH INTEGRATED MINI-JUNCTION BOX	09-28-2010
PCT/US2009/001815 03-24-2009	WO 2009/120302 10-01-2009	CHEMICAL TREATMENTS TO ENHANCE PHOTOVOLTAIC PERFORMANCE OF CIGS	10-24-2010